



INFORMATION DISCLOSURE 1449	Docket No.: MCA-437	Application No.: 09/890,290
	Applicant: Cheng, et al.	
	Filing Date: July 27, 2001	Group Art Unit: 1724

U.S. Patent Documents

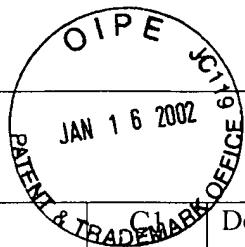
* Examiner's Initial	Ref	Document Number	Date	Name	Class	Subclass	Entered	Entered Appropriate
km	A1	4,902,456	02/90	Yen, et al.			JAN 28 2002	
	*A2	4,906,377	03/90	Yen, et al.				
	A3	4,990,294	02/91	Yen, et al.			TC 1700	
	A4	5,032,274	07/91	Yen, et al.				
	*A5	5,158,680	10/92	Kawai, et al.			RECEIVED	
	A6	5,490,931	02/96	Chung, et al.			JAN 22 2002	
	*A7	5,514,827	10/92	Ashelin, et al.			TC 1700	
	A8	5,695,702	12/97	Niermeyer				
	*A9	5,762,789	06/98	Reyes, et al.				
	*A10	5,855,783	01/99	Shucosky, et al.				

FOREIGN PATENT DOCUMENTS

	Ref	Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
km	*B1	DE 34 44 387	07/85	Germany				X
	*B2	EP 0 175 432	03/86	EPO				
	*B3	EP 0 217 482	04/87	EPO				
	B4	EP 0 299 459	01/89	EPO				
	B5	EP 0 340 732	11/89	EPO				
	B6	EP 0 343 247	11/89	EPO				
	B7	EP 0 559 149	09/93	EPO				
	B8	EP 0 803 281	10/97	EPO				
	B9	EP 0 855 212	07/98	EPO				
	B10	FR 2 566 003	12/85	France				X
	B11	WO 00/44479	08/00	PCT				
	B12	WO 00/44480	08/00	PCT				
	B13	WO 00/44482	08/00	PCT				
	B14	WO 00/44483	08/00	PCT				
	B15	WO 00/44484	08/00	PCT				
	*B16	WO 00/44485	08/00	PCT				

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OTHER DOCUMENTS

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Derwent Publication XP-002142276 Abstract of JP 04 354521

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JAN 22 2002

TC 1200

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JAN 28 2002

TC 1700

Examiner:

Date Considered:

Examiner: Initial if citation is considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

***Indicates cited art that has been previously forwarded to the USPTO and is not enclosed.**